

Our Case No. 9281-4822

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Akihiro Nakano et al.

Serial No.: 10/811,034

Filing Date: March 26, 2004

For: Plasma Processing Apparatus

Including A Plurality Of Plasma
Processing Units Having Reduced

Variation

Examiner: Not yet assigned

Group Art Unit No.: 1763

PETITION UNDER 37 CFR 1.182

Mail Stop Missing Parts Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

Applicants of the above-referenced application hereby petition under 37 CFR 1.182 and request that the Commissioner accord the later filing date of the application (the date deposited herein). Accompanying this petition, in accordance with the Notice of Omitted Items and 37 CFR 1.53(b), Applicants herein submit a copy of the Notice, missing Figs. 33 and 34, a new Declaration/Power of Attorney for the above-identified application, including reference to the missing Figs. 33 and 34, and the petition fee under 37 CFR 1.182.

Respectfully submitted,

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130.00 OP

Anthony P. Curtis, Ph.D. Registration No. 46,193 Agent for Applicants

BRINKS HOFER GILSON & LIONE P.O. BOX 10395 CHICAGO, ILLINOIS 60610 (312) 321-4200